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MS AF REPLY UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE

AMENDMENT TRANSMITTAL LETTER							EXAMINING GROUP	
Application No. 10/671,732-Conf. #006775		Filing Date September 29, 2003			Examiner	Art Unit		
					S. J. Lee	1752		
Tak	eshi KINSHO e	et al.						
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Docket No.: 0171-1022P

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Takeshi KINSHO et al.

Application No.: 10/671,732

Confirmation No.: 6775

Filed: September 29, 2003

Art Unit: 1752

For: POLYMERIZABLE SILICON-CONTAINING

 $COMPOUND, MANUFACTURING\ METHOD,$

POLYMER, RESIST COMPOSITION AND

PATTERNING PROCESS

Examiner: S. J. Lee

AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

MS AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated July 18, 2006, finally rejecting claim 1, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 11 of this paper.